

CORNERSTONE STANDARD COMPONENTS LIBRARY

(On 300 nm Si_3N_4 Platform)



Preface

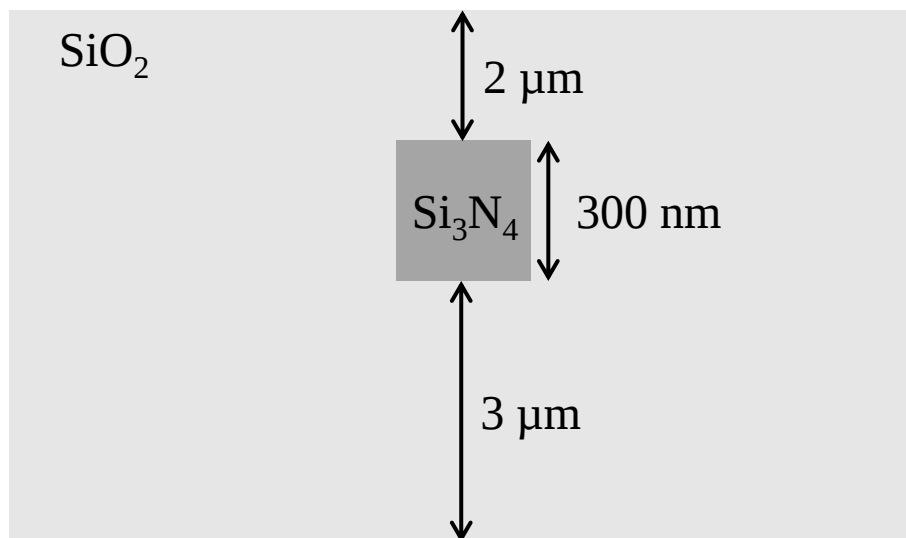
In this document, we summarise the up-to-date designs and their measurement results of our CORNERSTONE standard components on SiN platforms, at the same time we are optimising the current designs, adding in new designs, and gathering more measurement results.

List of Contents

- **SiN300nm 1550nm**
 - **SiN300nm 1550nm TE STRIP**
 - **SiN300nm 1550nm TE STRIP Grating Coupler**
 - **SiN300nm 1550nm TE STRIP 2x1 MMI**
 - **SiN300nm 1550nm TE STRIP 2x2 MMI**
 - **SiN300nm 1550nm TE STRIP 90 Degree Bend**
- **SiN300nm 1310nm**
- **SiN300nm 1310nm TE STRIP**
 - **SiN300nm 1310nm TE STRIP Grating Coupler**
 - **SiN300nm 1310nm TE STRIP 2x1 MMI**
 - **SiN300nm 1310nm TE STRIP 2x2 MMI**
 - **SiN300nm 1310nm TE STRIP 90 Degree Bend**

- **Wavelength: 1550 nm**
- **Platform: 300 nm Si_3N_4**

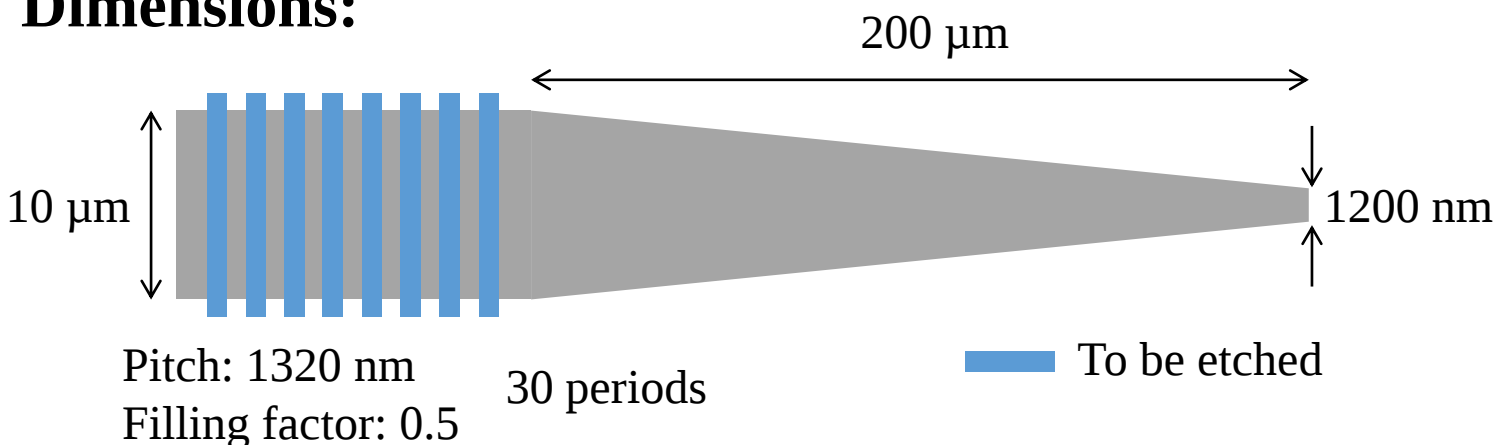
- Wavelength: 1550 nm
- Platform: 300 nm Si_3N_4
- **STRIP**



SiN300nm_1550nm_TE_STRIP_Grating_Coupler

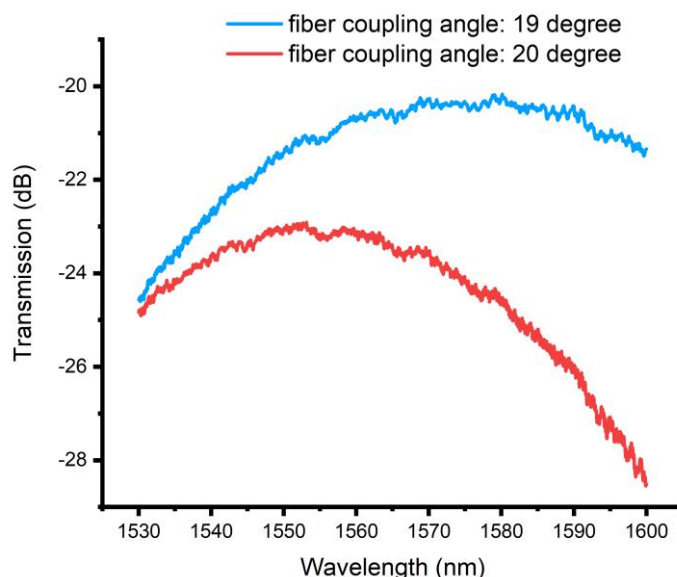
Platform:	300 nm Si ₃ N ₄
Wavelength:	1550 nm
Etching depth:	300 nm
Polarization:	TE
Cell name in GDS lib:	SiN300nm_1550nm_TE_STRIP_Grating_Coupler

Dimensions:



Fiber coupling angle: 19-20 degree

Measured transmission spectrum



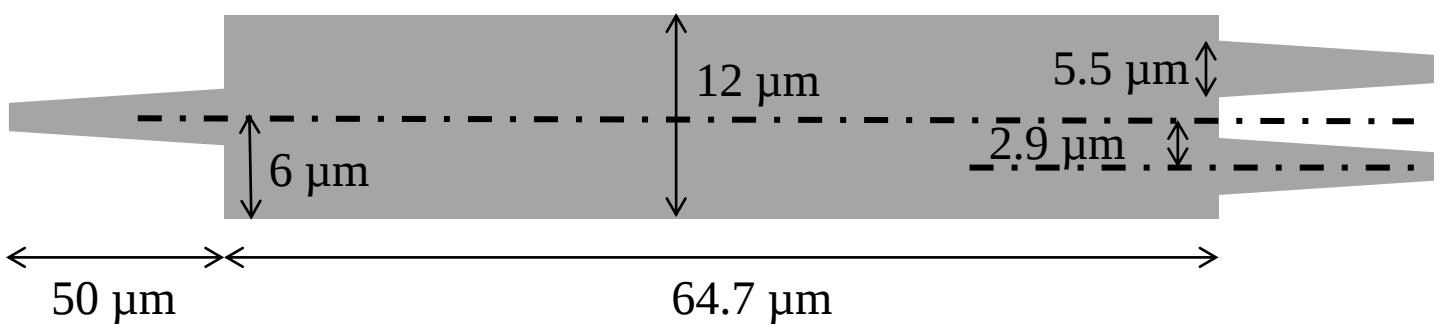
Transmission measured on a test structure as below, which includes two gratings.



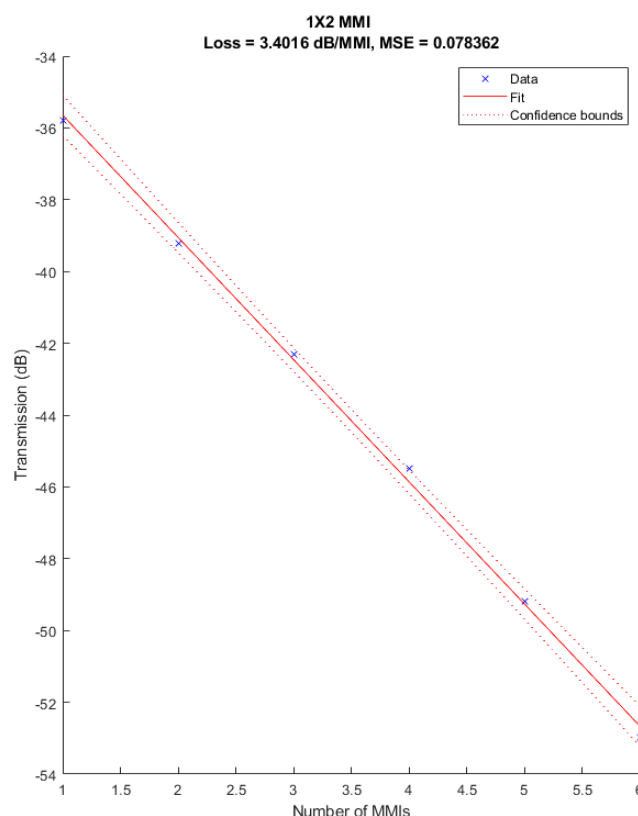
SiN300nm_1550nm_TE_STRIP_2x1_MMI

Platform:	300 nm Si ₃ N ₄
Wavelength:	1550 nm
Etching depth:	300 nm
Polarization:	TE
Cell name in GDS lib:	SiN300nm_1550nm_TE_STRIP_2x1_MMI

Dimensions:



Measurement results:

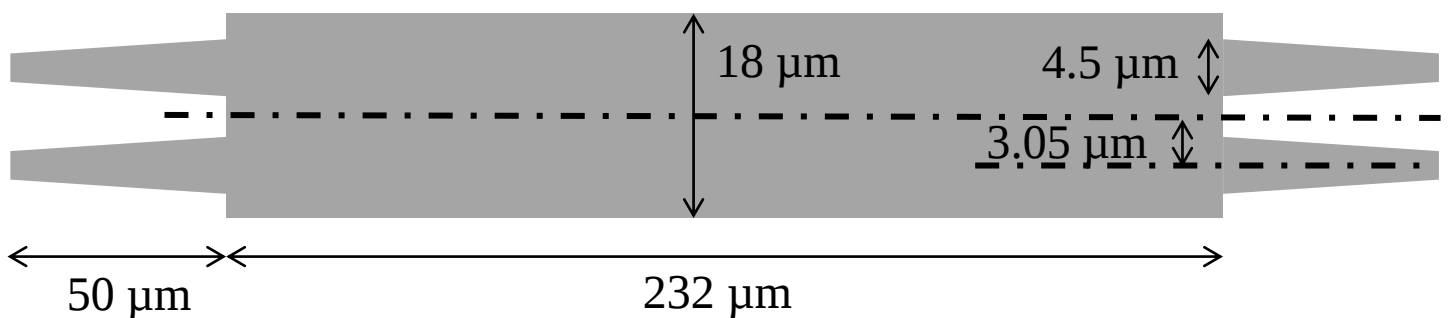


Transmission includes the measurement system loss, grating coupler loss and waveguide loss, as well as the measured device loss

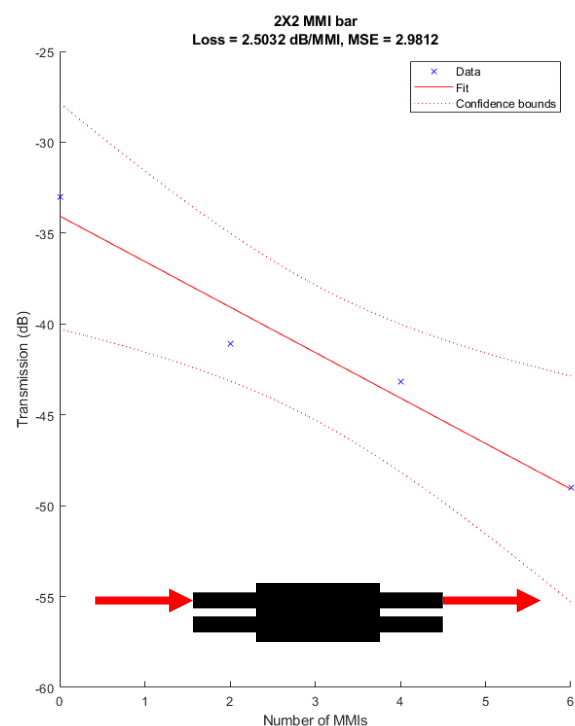
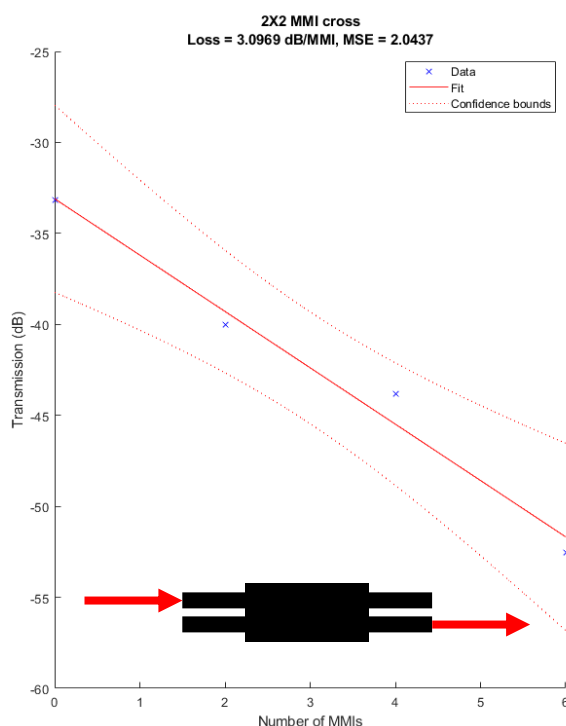
SiN300nm_1550nm_TE_STRIP_2x2_MMI

Platform:	300 nm Si ₃ N ₄
Wavelength:	1550 nm
Etching depth:	300 nm
Polarization:	TE
Cell name in GDS lib:	SiN300nm_1550nm_TE_STRIP_2x2_MMI

Dimensions:



Measurement results:



Transmission includes the measurement system loss, grating coupler loss and waveguide loss, as well as the measured device loss

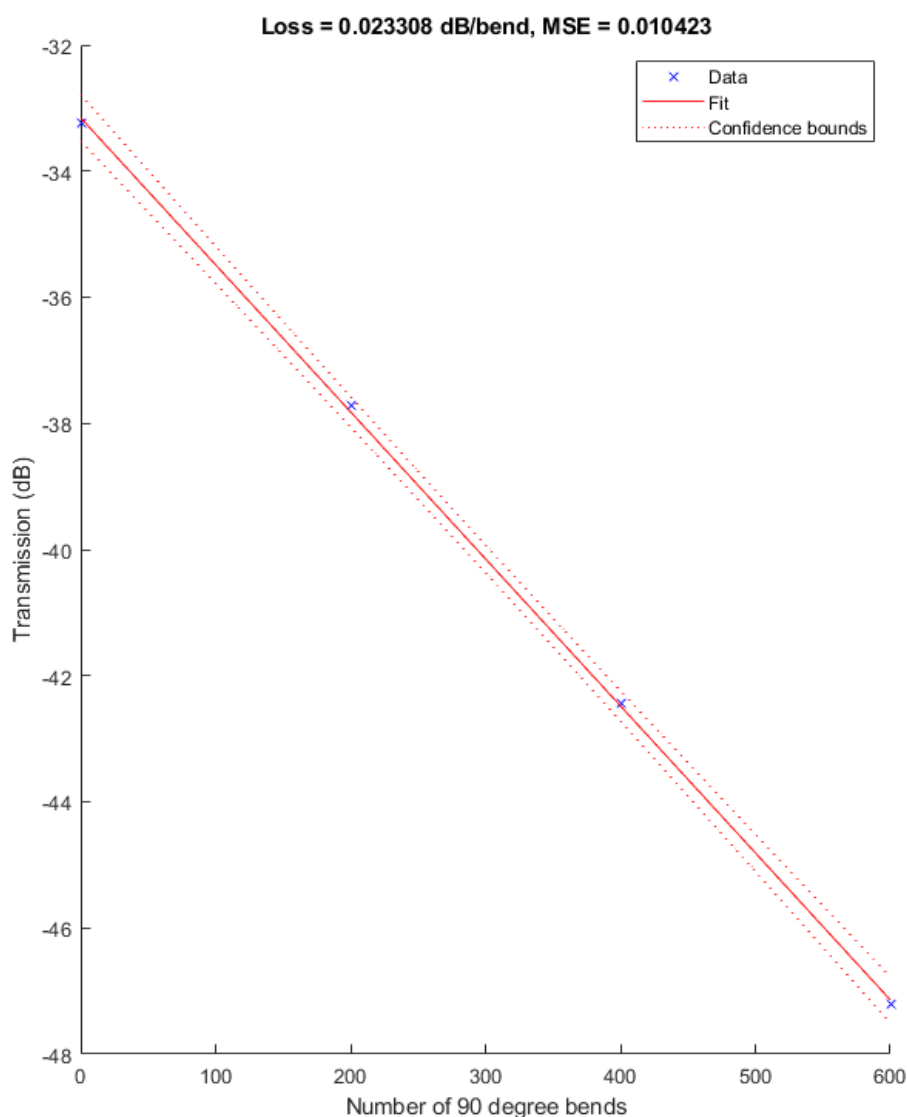
SiN300nm_1550nm_TE_STRIP_90_Degree_Bend

Platform:	300 nm Si ₃ N ₄
Wavelength:	1550 nm
Etching depth:	300 nm
Polarization:	TE
Cell name in GDS lib:	SiN300nm_1550nm_TE_STRIP_90_Degree_Bend

(Suggested bend radius: 80 μ m)

Measurement results:

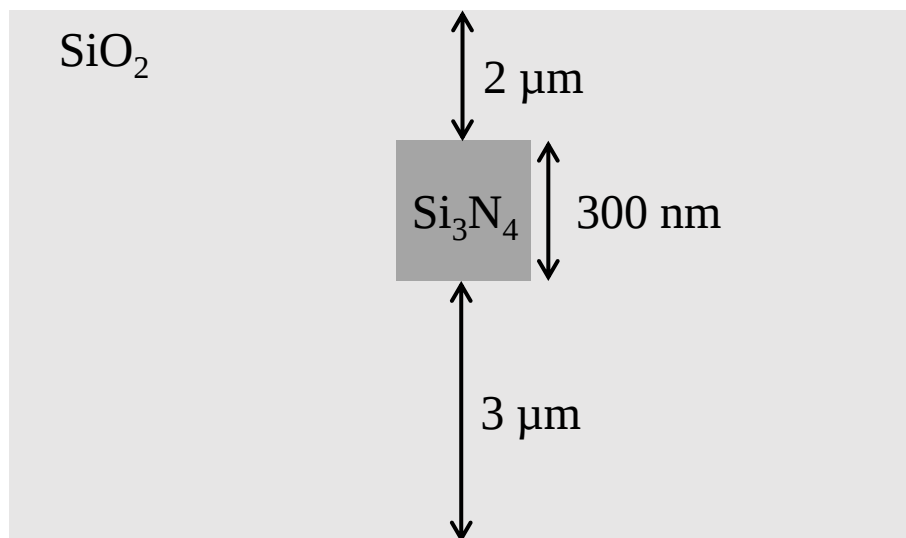
(per 90° bend)



Transmission includes the measurement system loss, grating coupler loss and waveguide loss, as well as the measured device loss

- **Wavelength: 1310 nm**
- **Platform: 300 nm Si_3N_4**

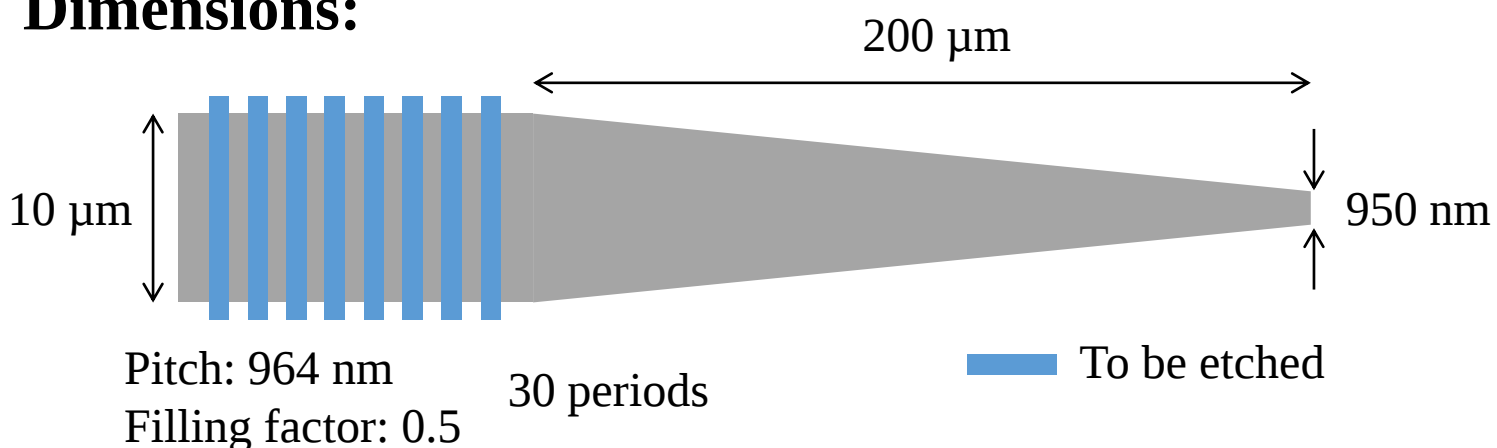
- Wavelength: 1310 nm
- Platform: 300 nm Si_3N_4
- **STRIP**



SiN300nm_1310nm_TE_STRIP_Grating_Coupler

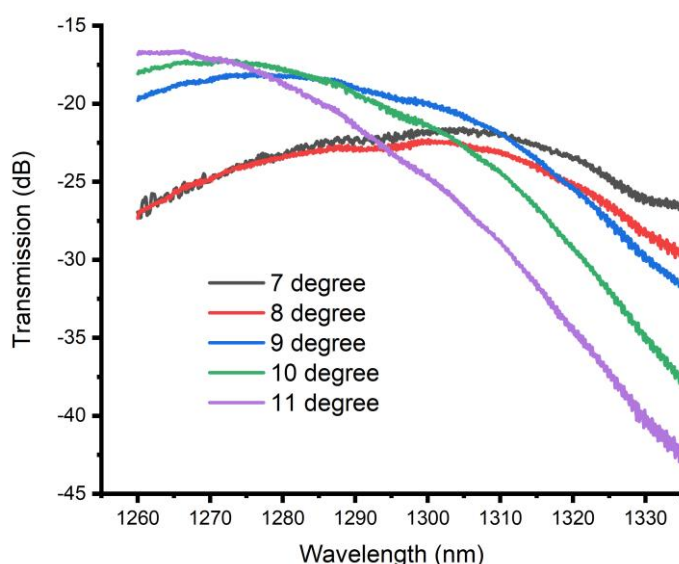
Platform:	300 nm Si ₃ N ₄
Wavelength:	1310 nm
Etching depth:	300 nm
Polarization:	TE
Cell name in GDS lib:	SiN300nm_1310nm_TE_STRIP_Grating_Coupler

Dimensions:



Fiber coupling angle: 7-11 degree

Measured transmission spectrum



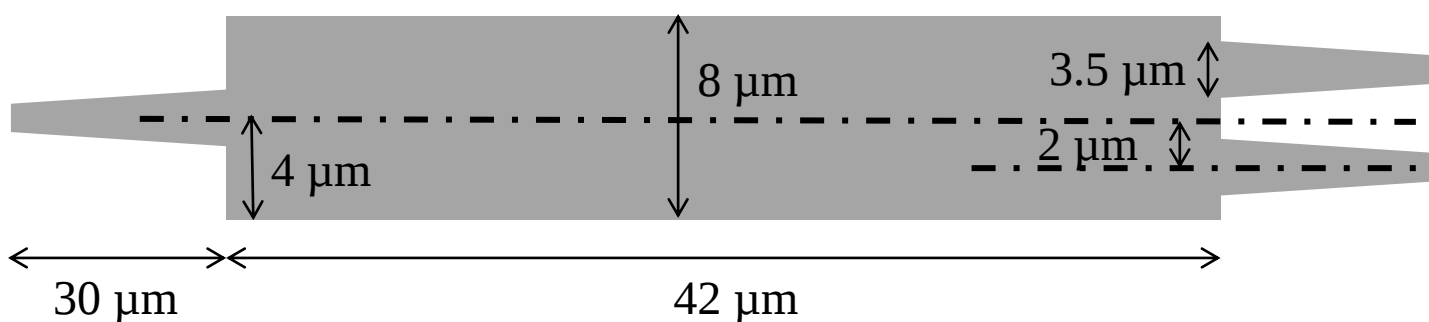
Transmission measured on a test structure as below, which includes two gratings.



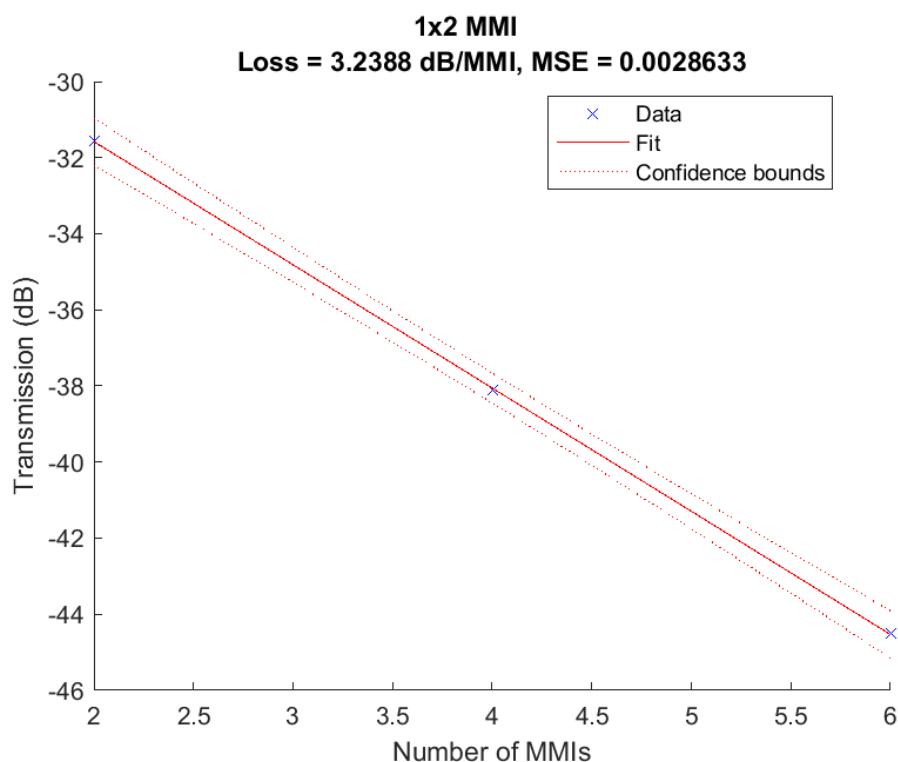
SiN300nm_1310nm_TE_STRIP_2x1_MMI

Platform:	300 nm Si ₃ N ₄
Wavelength:	1310 nm
Etching depth:	300 nm
Polarization:	TE
Cell name in GDS lib:	SiN300nm_1310nm_TE_STRIP_2x1_MMI

Dimensions:



Measurement results:

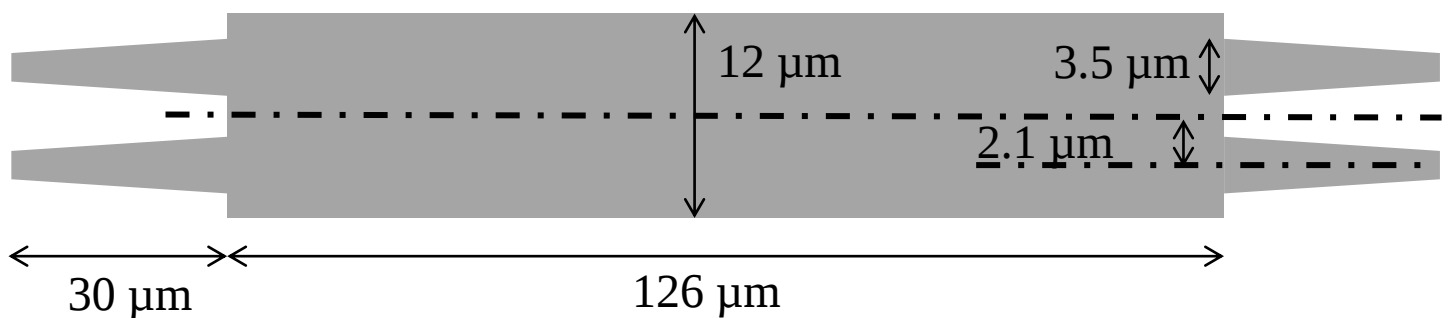


Transmission includes the measurement system loss, grating coupler loss and waveguide loss, as well as the measured device loss

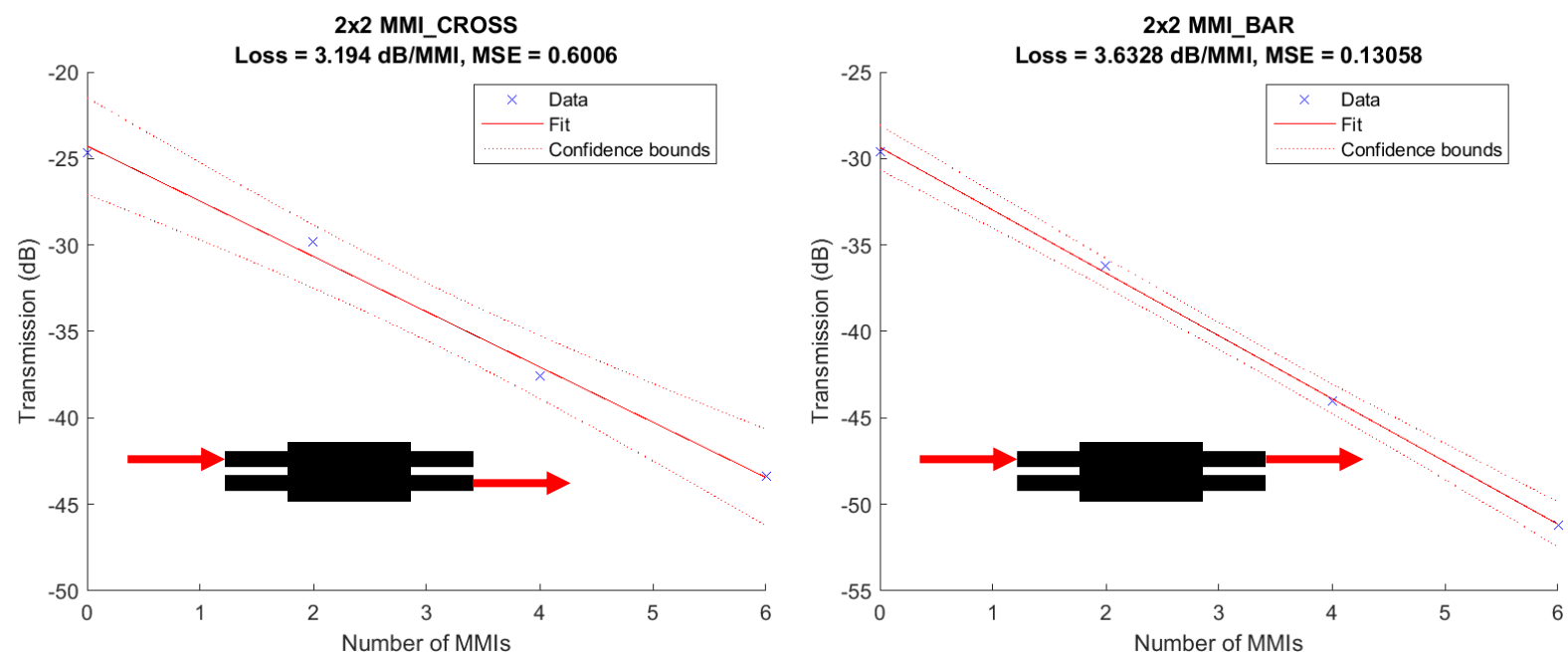
SiN300nm_1310nm_TE_STRIP_2x2_MMI

Platform:	300 nm Si ₃ N ₄
Wavelength:	1310 nm
Etching depth:	300 nm
Polarization:	TE
Cell name in GDS lib:	SiN300nm_1310nm_TE_STRIP_2x2_MMI

Dimensions:



Measurement results:



Transmission includes the measurement system loss, grating coupler loss and waveguide loss, as well as the measured device loss

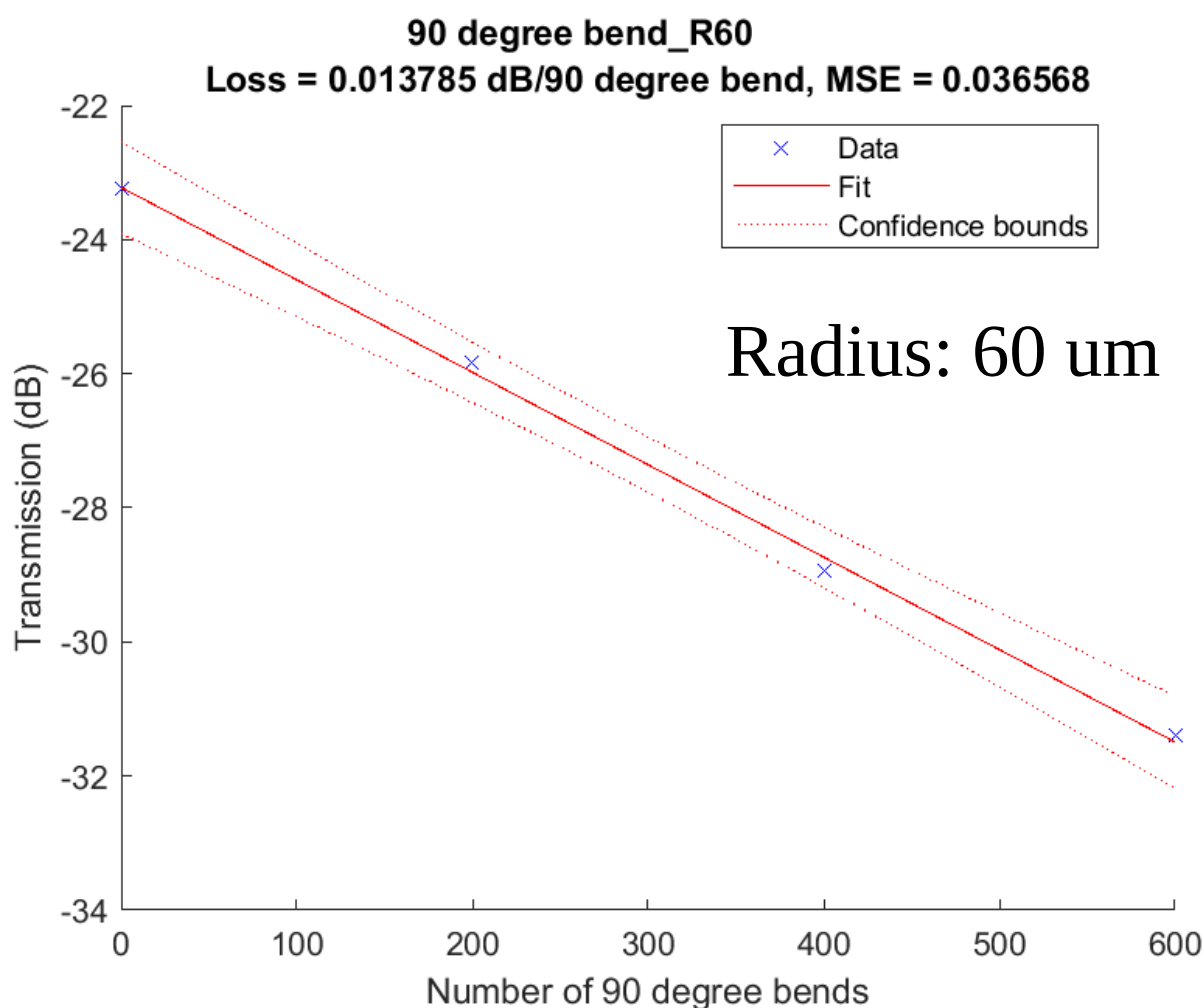
SiN300nm_1310nm_TE_STRIP_90_Degree_Bend

Platform:	300 nm Si ₃ N ₄
Wavelength:	1310 nm
Etching depth:	300 nm
Polarization:	TE
Cell name in GDS lib:	SiN300nm_1310nm_TE_STRIP_90_Degree_Bend

(Suggested bend radius: 60 μ m)

Measurement results:

(per 90° bend)



Transmission includes the measurement system loss, grating coupler loss and waveguide loss, as well as the measured device loss